

Notice of References Cited	Application/Control No. 10/584,501		Applicant(s)/Patent Under Reexamination MEINDS ET AL.	
	Examiner M GOOD JOHNSON		Art Unit 2628	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,985,156	01-2006	Wang et al.	345/582
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
	U	Ren et al., Object Space EWA Surface Splatting: A Hardware Accelerated Approach to High Quality Point Rendering, pages 461-470, EUROGRAPHICS, Volume 21, 2002.			
	V				
	W				
	X				

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.